



ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

March 31, 2026	
IGI Report Number	LG785614037
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	ROUND BRILLIANT
Measurements	7.49 - 7.52 X 4.50 MM

GRADING RESULTS

Carat Weight	1.56 CARAT
Color Grade	E
Clarity Grade	VVS 2
Cut Grade	IDEAL

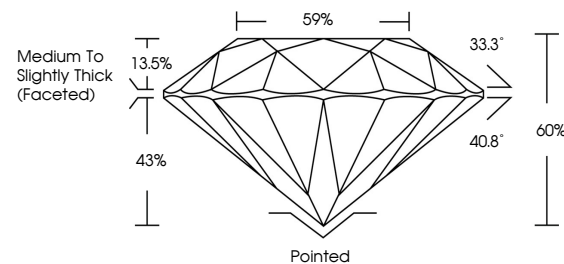
ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	 LG785614037

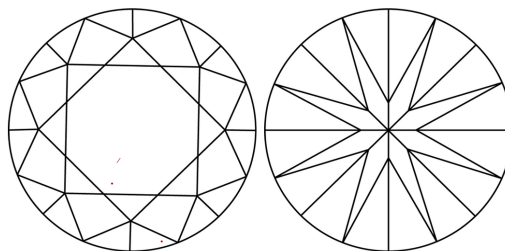
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

LG785614037
Report verification at igi.org

PROPORTIONS



CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.



Sample Image Used

COLOR

D E F G H I J Faint Very Light Light

CLARITY

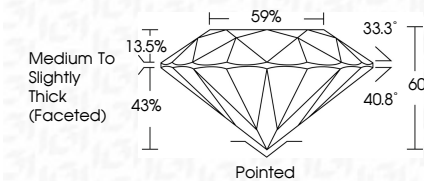
FL	IF	VVS ¹⁻²	VS ¹⁻²	SI ¹⁻²	I ¹⁻³
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included



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www.igi.org

March 31, 2026	GI Report No. LG785614037
ROUND BRILLIANT	
1.56 CARAT	
E	
VVS 2	
IDEAL	
60%	
89%	
Medium to Slightly Thick (Faceted)	
Polished	
EXCELLENT	
B'CELENT	
NONE	
1691 LG785614037	
Comments:	
Created by: Cheryl Diamond was	
Inspected by: Diamond Vapor Deposition	
(CVD) growth process.	
Type IIG	